

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of

Group 1795

Steven A. Soper *et al.*

Examiner Lee, Sin J.

Serial No. 10/734,816

Confirmation No. 3513

Filing Date: December 12, 2003

For: Photoresist-Free Micropatterning on Polymer Surfaces (File Soper 0023.1)

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**Request for Continued Examination  
and  
REQUEST FOR TELEPHONIC INTERVIEW**

This Request for Continued Examination is submitted in response to the June 21, 2010 Office Action. Please amend the Claims as shown in Appendix A.

The \$405 small entity fee for this Request for Continued Examination is being paid online. Also being paid online is the \$555 small entity fee for a three-month extension of time, to extend the time for response from September 21, 2010 to December 21, 2010. If either of these amounts is incorrect, or if any additional fees should be due, please refer to the Deposit Account Authorization previously filed with this application. If any additional extension of time is required, please consider this paper a petition for the total extension of time required. See 37 C.F.R. § 1.136(a)(3).

**Please note that Applicants are requesting a telephonic interview before the next office action is prepared,** unless the Office concurs that the case is now in condition for allowance.